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## **BIB DATA SHEET**

## **CONFIRMATION NO. 9812**

10/597,353 07/06/2007 711 2113 09792909-6735  RULE  APPLICANTS	SERIAL NUME	RIAL NUMBER FILING O				GROUP ART UNIT		ATTORNEY DOCKET			
APPLICANTS Yoshito Katano, Tokyo, JAPAN; Tadashi Yoshida, Kaangawa, JAPAN; Kazuhiro Sako, Tokyo, JAPAN; This application is a 371 of PCT/JP05/01105 01/27/2005 ***FOREIGN APPLICATIONS **** JAPAN 2004-019278 01/28/2004 *** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/21/2007  Foreign Priority claimed	10/597,353					711		2113 0			
Yoshito Katano, Tokyo, JAPAN; Tadashi Yoshida, Kanagawa, JAPAN; Kazuhiro Sako, Tokyo, JAPAN; *** CONTINUING DATA **********************************			RUL	E							
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JAPAN 2004-019278 01/28/2004  *** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/21/2007  Foreign Priority claimed											
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35 USC 119(a-d) conditions met											
Acknowledged Examiner's Signature Thitials JAPAN 4 8 2  ADDRESS  SONNENSCHEIN NATH & ROSENTHAL LLP P.O. BOX 061080 WACKER DRIVE STATION, SEARS TOWER CHICAGO, IL 60606-1080 UNITED STATES  TITLE  Semiconductor Device and Processing Method for Starting the Same  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: 1.18 Fees (Issue) Other	35 USC 119(a-d) conditions met   ✓ Yes   No Verified and /YOLANDA L WILSON/							_		INDEPENDENT CLAIMS	
SONNENSCHEIN NATH & ROSENTHAL LLP P.O. BOX 061080 WACKER DRIVE STATION, SEARS TOWER CHICAGO, IL 60606-1080 UNITED STATES  TITLE  Semiconductor Device and Processing Method for Starting the Same  FILING FEE RECEIVED 1130  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:    All Fees   All Incompany						JAPAN	4	8		2	
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